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Search Results - Record(s) 1 through 12 of 12 returned.

 1. Document ID: US 5441599 A

L19: Entry 1 of 12

File: USPT

Aug 15, 1995

US-PAT-NO: 5441599

DOCUMENT-IDENTIFIER: US 5441599 A

TITLE: Lightly doped drain etch method for semiconductor manufacture

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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 2. Document ID: US 5390785 A

L19: Entry 2 of 12

File: USPT

Feb 21, 1995

US-PAT-NO: 5390785

DOCUMENT-IDENTIFIER: US 5390785 A

TITLE: Pressurized sealable transportable containers for storing a semiconductor wafer in a protective gaseous environment

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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 3. Document ID: US 5311060 A

L19: Entry 3 of 12

File: USPT

May 10, 1994

US-PAT-NO: 5311060

DOCUMENT-IDENTIFIER: US 5311060 A

TITLE: Heat sink for semiconductor device assembly

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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 4. Document ID: US 5259254 A

L19: Entry 4 of 12

File: USPT

Nov 9, 1993

US-PAT-NO: 5259254

DOCUMENT-IDENTIFIER: US 5259254 A

TITLE: Sample introduction system for inductively coupled plasma and other gas-phase, or particle, detectors utilizing ultrasonic nebulization, and method of use

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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5. Document ID: US 5256235 A

L19: Entry 5 of 12

File: USPT

Oct 26, 1993

US-PAT-NO: 5256235

DOCUMENT-IDENTIFIER: US 5256235 A

TITLE: Method for forming long thin flexible laminates

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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6. Document ID: US 5252700 A

L19: Entry 6 of 12

File: USPT

Oct 12, 1993

US-PAT-NO: 5252700

DOCUMENT-IDENTIFIER: US 5252700 A

TITLE: Heat-resistant adhesive and method of adhesion by using adhesive

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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7. Document ID: US 5161465 A

L19: Entry 7 of 12

File: USPT

Nov 10, 1992

US-PAT-NO: 5161465

DOCUMENT-IDENTIFIER: US 5161465 A

TITLE: Method of extending the useful life and enhancing performance of lithographic printing plates

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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8. Document ID: US 5135779 A

L19: Entry 8 of 12

File: USPT

Aug 4, 1992

US-PAT-NO: 5135779

DOCUMENT-IDENTIFIER: US 5135779 A

TITLE: Method for conditioning an organic polymeric material

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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9. Document ID: US 4894421 A

L19: Entry 9 of 12

File: USPT

Jan 16, 1990

US-PAT-NO: 4894421
 DOCUMENT-IDENTIFIER: US 4894421 A
 TITLE: Low-crystalline propylene random copolymer composition, process for production thereof, and polypropylene composite laminated structure

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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10. Document ID: US 4529651 A

L19: Entry 10 of 12

File: USPT

Jul 16, 1985

US-PAT-NO: 4529651
 DOCUMENT-IDENTIFIER: US 4529651 A
 TITLE: Magnetic recording medium having organic protective overlayer

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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11. Document ID: US 3789321 A

L19: Entry 11 of 12

File: USPT

Jan 29, 1974

US-PAT-NO: 3789321
 DOCUMENT-IDENTIFIER: US 3789321 A
 TITLE: ELECTRON BEAM-PUMPED GAS LASER SYSTEM

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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12. Document ID: US 3686374 A

L19: Entry 12 of 12

File: USPT

Aug 22, 1972

US-PAT-NO: 3686374
 DOCUMENT-IDENTIFIER: US 3686374 A
 TITLE: GAS ASSISTED ELECTROSTATIC PINNING

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KMC	Draw Desc	Image
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Terms	Documents
('3686374' '5135779' '5390785' '5252700' '5256235' '4529651' '3789321' '5441599' '5311060' '5161465' '4894421' '5259254')[PN]	12

Display

50

Documents, starting with Document: 12

Display Format: TI [Change Format](#)

Search History

Today's Date: 7/12/2000

DB Name

DB Name	Query	Hit Count	Set Name
USPT	I62 and I63	0	
USPT	I60 and I37	22	L64
USPT	I30 and I61	2	L63
USPT	I60 and I39	265	L62
USPT	I59 and technology.asp.	272	L61
USPT	I45 and micron.asp.	291	L60
USPT	(MICRONTECHNOLOGY MICRONTECHNOLOGY-INC)!	1	L59
USPT	(MICRONTECHNOLOGY MICRONTECHNOLOGY-INC)!	1	L58
USPT	I55 and I37	7	L57
			L56

USPT	I54 and I34	
		38
USPT		L55
	I53 and I30	
		143
USPT		L54
	I39 same I52	
		8036
USPT		L53
	gas with substrate	
		24881
USPT		L52
	I48 and I30	
		2
USPT		L51
	I48 and I30	
		2
USPT		L50
	I48 and seal\$	
		10
USPT		L49
	I39 and I47	
		82
USPT		L48
	I45 and I6 and (I7 or I8)	
		84
USPT		L47
	(156/643 156/643-642 156/643E 156/643-646 156/643-659 "156/643.07"	
	"156/643.1" "156/643.11"	
	"156/643.7")!	
		7778
USPT		L46
	(156/643 156/643-642 156/643E 156/643-646 156/643-659 "156/643.07"	
	"156/643.1" "156/643.11"	

"156/643.7")!

USPT	7778	1.45
	0	
USPT	0	1.44
	0	
USPT	140 and ((156/643)!.CCLS.)	1.43
	0	
USPT	(((156/643)!.CCLS.)	1.42
	0	
USPT	138 and 139	L41
	658	
USPT	(semiconduct\$ or semi-conduct\$ or electrod\$)	L40
	380691	
USPT	130 and 137	L39
	1515	
USPT	136 or 111 or 114 or 113	L38
	41769	
USPT	caption	L37
	157	
USPT	133 and 134	L36
	1	
USPT	micron or micrometer or micromiter	L35

200209

USPT 132 and (113 or 114 or 111) 9 L34

USPT 131 and (15 or 16) 39 L33

USPT 130 and (17 or 18) 54 L32

USPT heat\$.clm. and transfer\$.clm. 32586 L31

USPT 127 and 128 1 L30

USPT seal.clm. 93342 L29

USPT 126 and (15 or 16) 59 L28

USPT 125 and (111 or 114) 59 L27

USPT (16 or 17) and (semiconduct\$ or semi-conduct\$ or conduct\$).ti.ab.clm. 1327 L26

USPT ('5390785' '5311060' '5259254' '5161465')[PN] 4 L25

USPT body.clm or hold\$.clm. or held.clm. or clamp.clm. 346092 L24

USPT L23
('4726879' '4676867')[PN]
2
USPT L22
|6 and (|7 or |8) and (|11 or |13 or |14)
21
USPT L21
|18 and (semiconduct\$ or semi-conduct\$ or conduct\$).ti,ab,clm.
10
USPT L20
('3686374' '5135779' '5390785' '5252700' '5256235' '4529651' '3789321' '5441599'
'5311060' '5161465' '4894421'
'5259254')[PN]
12
USPT L19
|11 and |6
23
USPT L18
|12 and |6
0
USPT L17
|12 or |15
594
USPT L16
(|7 or |8) and |14
580
USPT L15
polyimide or poly-imide
39728
USPT L14
polyimide
39708
USPT L13
|11 and (|7 or |8)

	42	
USPT		L12
	kapton	
	4489	
USPT		L11
	I8 and I5	
	2134	
USPT		L10
	I8 and I6	
	122	
USPT		L9
	plasma.clm. and etch\$.clm.	
	4394	
USPT		L8
	plasma.clm. and ethch\$.clm.	
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USPT		1.7
	helium.clm or he.clm.	
	8128	
USPT		L6
	gas\$.clm.	
	211305	
USPT		L5
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USPT		L4
	((118 or 216 or 204 or 438/)!.Clas.)	
	0	
USPT		L3
	((118 or 216 or 204 or 438/)!.CCLS.)	